

# DATA ANALYSIS B-DOPED DIAMOND FILMS

## 1) ATOMIC + KELVIN PROBE FORCE MICROSCOPY

↳ ANALYSIS WITH GWYDDION SOFTWARE → PHYSICALLY SQUARE

↳ TOPOGRAPHIC IMAGES VS PHASE IMAGES VS POTENTIAL IMAGES

↳ NEED TO BE FLATTENED

↳ STARTING POINT: { MASK OUTLIERS  
+  
REMOVE PARABOLIC BACKGROUND

↳ FROM TOPO IMAGES → TERRACES/GROOVES STATISTICS

↳ SURFACE ROUGHNESS

↳ FRACTAL DIMENSION

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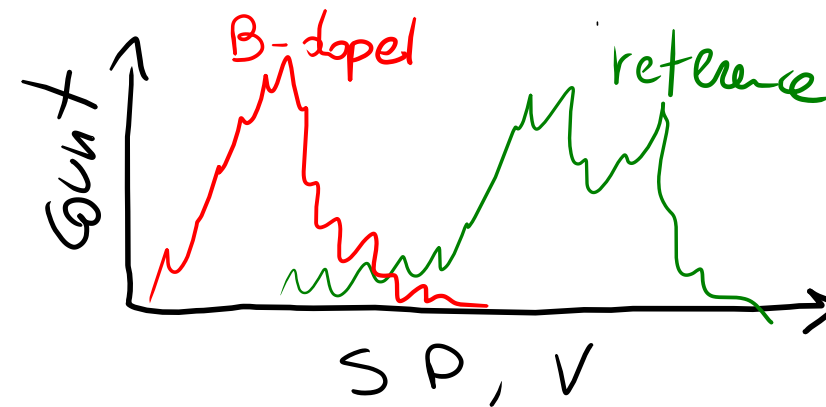
↳ TOPOGRAPHIC IMAGES VS PHASE IMAGES VS POTENTIAL IMAGES

↳ FROM POTENTIAL IMAGES OF BOTH **B-DOPED** AND **REFERENCE** FILMS

↳ BEWARE CONTAMINATIONS! → ANALYZE ONLY CLEAN AREAS

↳ PHASE IMAGE MAY HELP

↳ BUILD HISTOGRAMS



↳ DIFFERENCE IN AVERAGE VALUES GIVES  $\Delta E_F$  →

FERMI LEVEL  
SHIFT DUE  
TO DOPANTS

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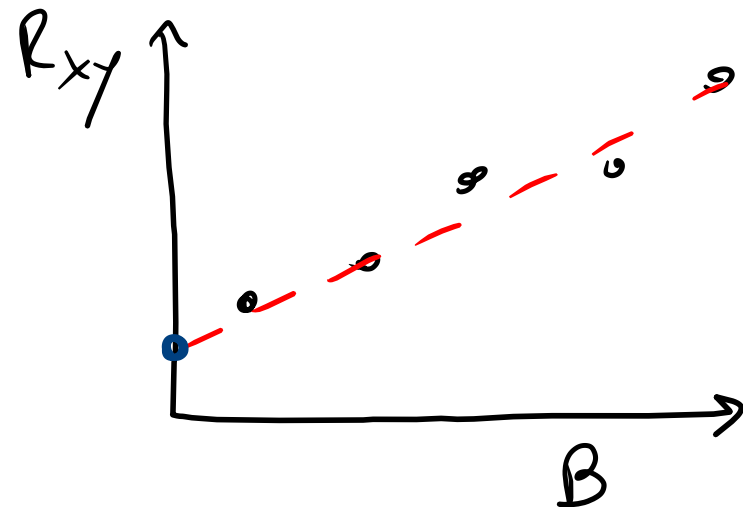
## 2) SHEET RESISTANCE AND HALL EFFECT

$$\hookrightarrow R = \rho \frac{1}{t} \frac{l}{w} \Rightarrow R_s = \frac{\rho}{t} = R \frac{w}{l}$$

INDEPENDENT ON ASPECT RATIO  
DEPENDENT ON THICKNESS

$\hookrightarrow$  OBTAINED BY SOLVING THE VAN DER PAUL EQ.

$\hookrightarrow R_H: R_{xy}(B) = R_r + R_H \cdot B \rightarrow R_{xy}$  OBTAINED BY AVERAGING THE  $R$  vs  $B$  CURVES IN THE TWO TRANSVERSE CONFIGURATIONS



$\rightarrow$  LINEAR FIT



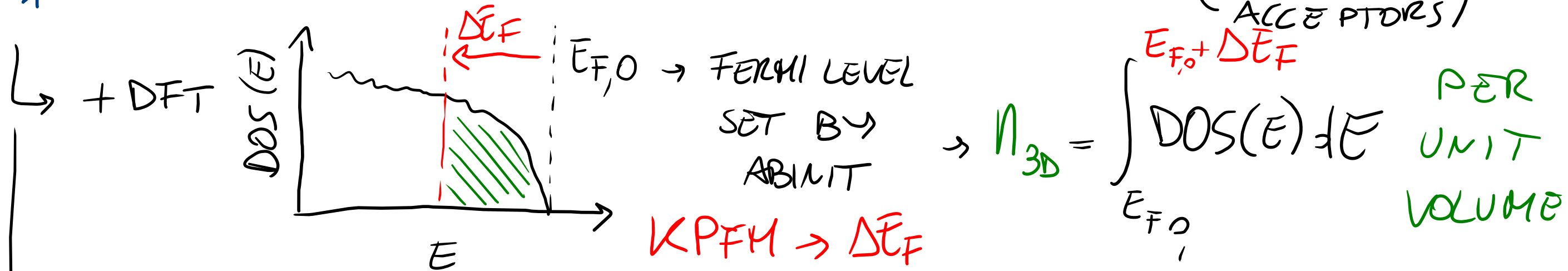
SLOPE

$$\rightarrow R_H = \frac{1}{e n_H} \rightarrow \text{(HALL) CARRIER DENSITY PER UNIT SURFACE}$$

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## 2) SHEET RESISTANCE AND HALL EFFECT

→  $n_H$  → SIGN? → ELECTRON OR HOLE-LIKE QUASIPARTICLES (DONORS vs ACCEPTORS)



→ ESTIMATE FILM THICKNESS:  $t \approx n_H / n_{3D}$  (CAREFUL ABOUT UNITS...)

→ COMBINE:  $R_S^{-1} = e n_H \mu_H$  → MOBILITY → COMPARE WITH LITERATURE

+ BOLTZMANN →  $\mu = \frac{e \tau}{m^*}$  → IOFFE REGEL PARAMETER

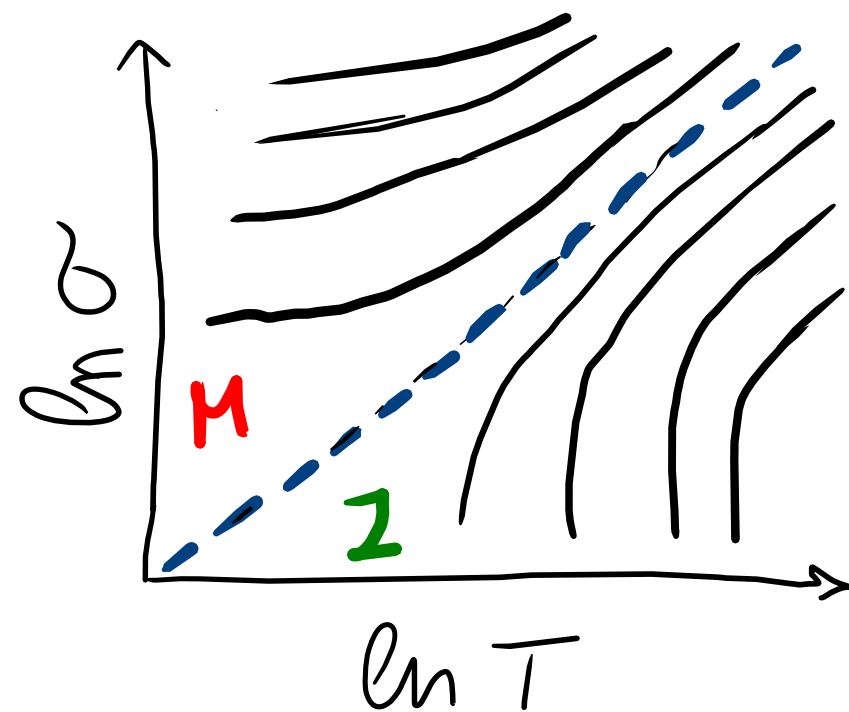
$x = \frac{\Delta E_F \tau}{\hbar}$  ASSESS IMT

DFT →  $m^*$

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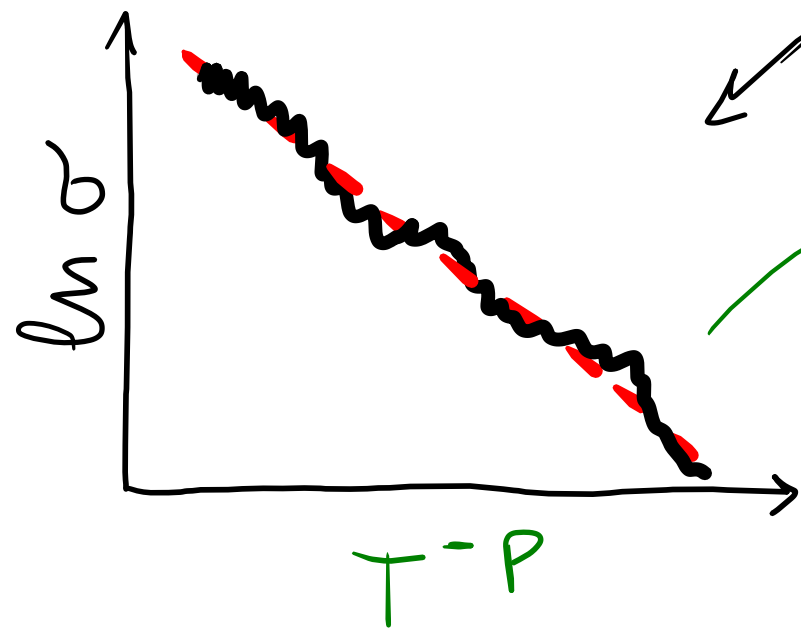
## 3) RESISTIVITY VS TEMPERATURE

→ ASSESS INSULATOR-TO-METAL TRANSITION



$\sigma \propto T^\beta$   $\left\{ \begin{array}{l} \beta < 1/3 \rightarrow \text{HEAVILY DISORDERED METAL} \\ \beta = 1/3 \rightarrow \text{I-M TRANSITION} \\ \beta > 1/3 \rightarrow \text{INSULATOR} \end{array} \right\}$  QUANTUM CRITICAL REGIME

$\sigma \propto \exp \left[ - \left( T_0 / T \right)^P \right] \rightarrow \text{STANDARD INSULATOR}$

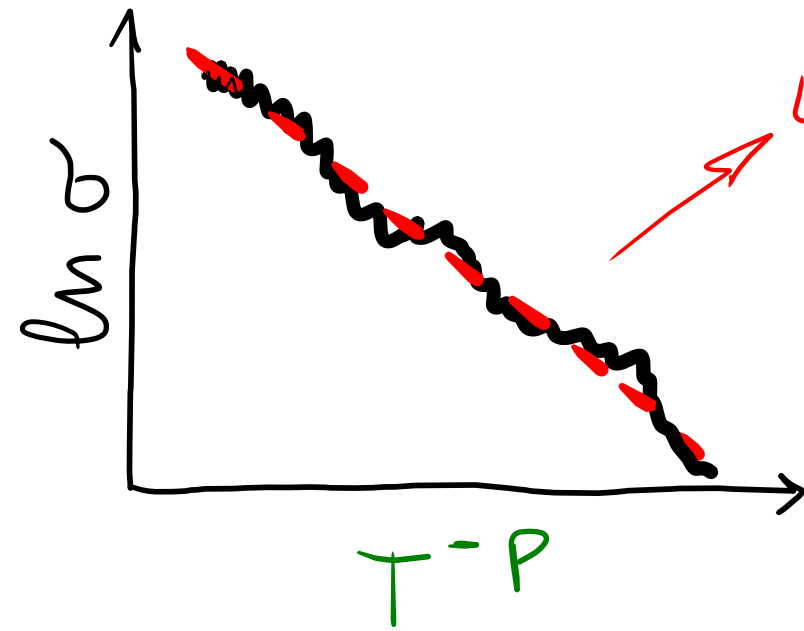


FIND  $P$  THAT BEST REALIZES LINEAR BEHAVIOR(S)

$\left\{ \begin{array}{l} P = 1 \rightarrow \text{NEAREST-NEIGHBOR HOPPING} \\ P = 1/2 \rightarrow \text{EFROS-SHLOVSKII VARIABLE RANGE HOPPING} \\ P = 1/3, 1/4 \rightarrow \text{2D, 3D MOTT VARIABLE RANGE HOPPING} \end{array} \right.$

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## 3) RESISTIVITY VS TEMPERATURE

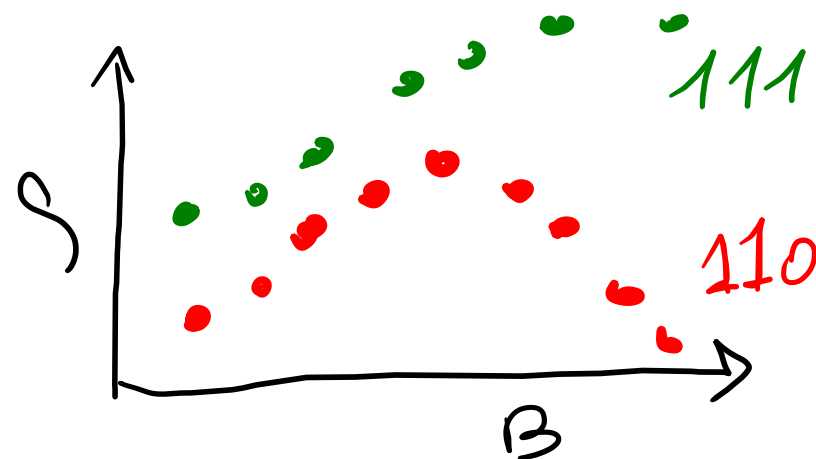


LINEAR FIT → FIND  $T_0 = f(p, \text{DOS}(\bar{E}_F), \xi_{loc})$  DFT + KP FM LOCALIZATION LENGTH

→ FIND  $R_{hop} = f(p, \xi_{loc}, T)$  HOPPING LENGTH

→ COMPARE WITH LITERATURE, CELL SIZE, FILM THICKNESS, SURFACE ROUGHNESS...

## 4) RESISTIVITY VS MAGNETIC FIELD



→ POSITIVE MR AT LOW B + "NEGATIVE" MR AT HIGH B  
IS SOMEWHAT UNUSUAL

→ SEARCH THE LITERATURE FOR AN EXPLANATION AND IDEALLY A FITTING MODEL  $f(\xi_{loc})$ ...